Inventor: Jaso et al Serial No.: Not Yet Assigned Docket No.: 2269-5593US

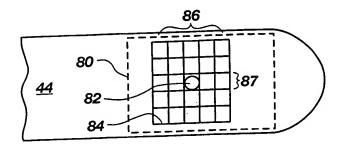


FIG. 6

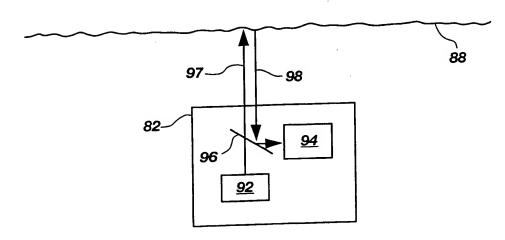


FIG. 7

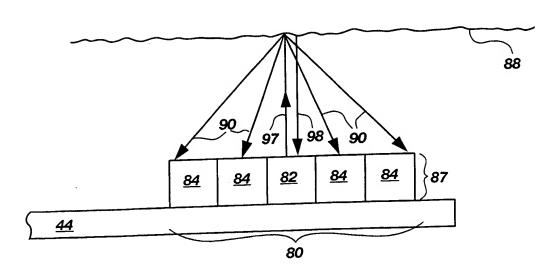


FIG. 8

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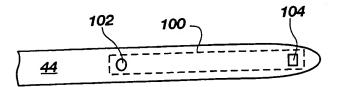
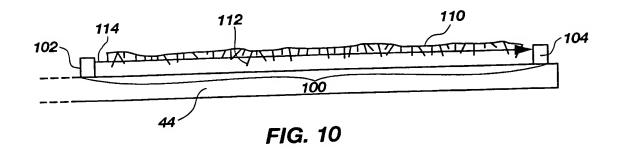


FIG. 9



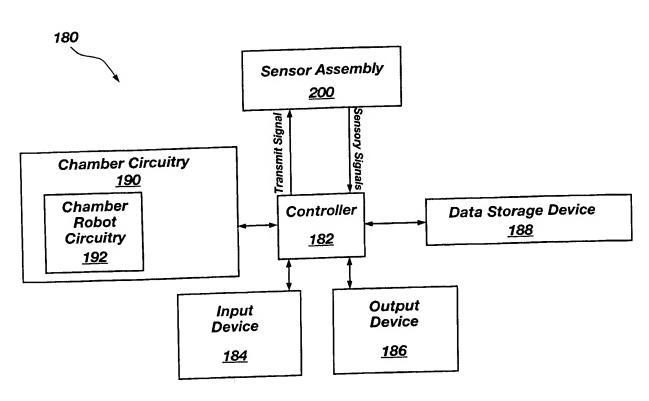


FIG. 11

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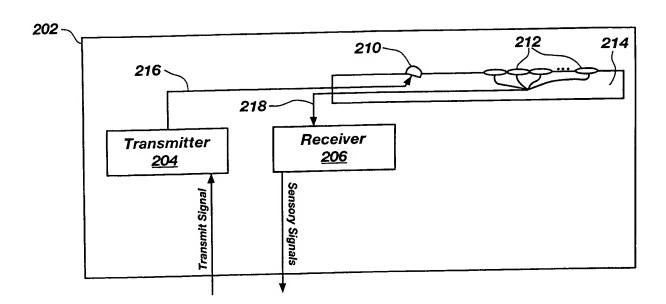


FIG. 12A

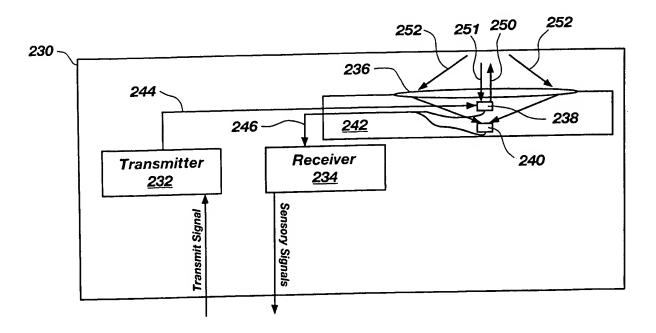


FIG. 12B

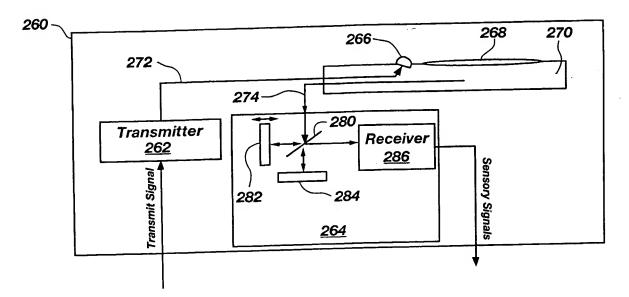


FIG. 12C

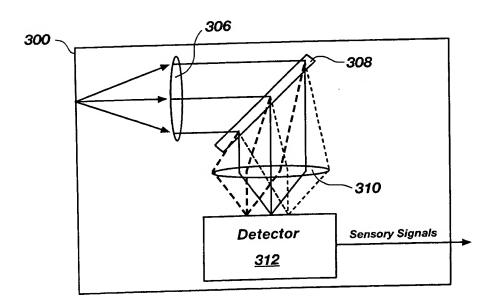


FIG. 13

Inventor: Jaso et al Serial No.: Not Yet Assigned Docket No.: 2269-5593US

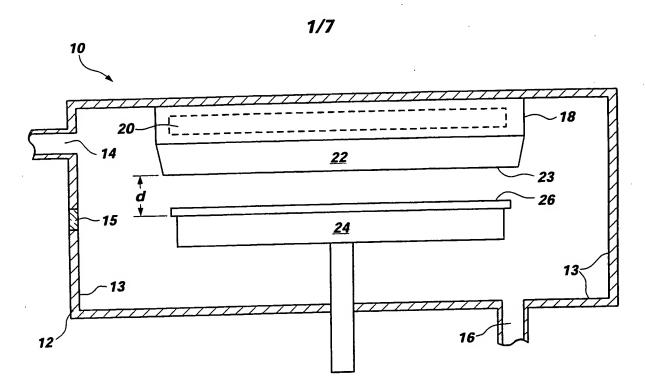


FIG. 1 (PRIOR ART)

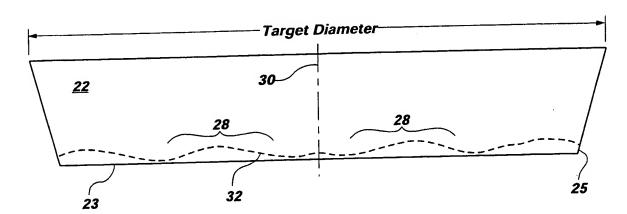


FIG. 2 (PRIOR ART)

TITLE: APPARATUS, METHOD AND SYSTEM FOR MONITORING CHAMBER PARAMETERS ASSOCIATED WITH A DEPOSITION PROCESS Inventor: Jaso et al Serial No.: Not Yet Assigned Docket No.: 2269-5593US

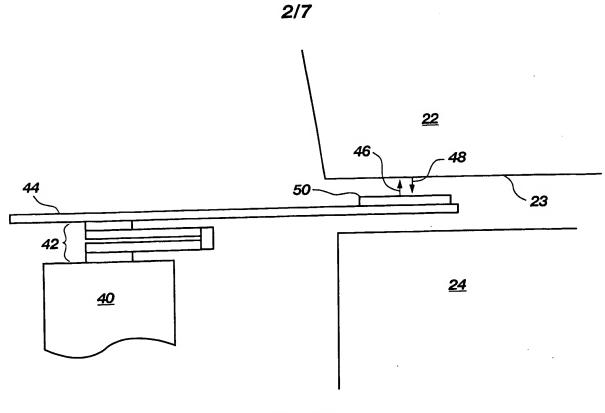


FIG. 3A

